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Dated: April 30, 2009  
Electronic Signature for James E. Armstrong, IV: /James E. Armstrong, IV/

Docket No.: 80585(302765)  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Toshiro Yamada et al.

Application No.: 10/520,272

Confirmation No.: 4526

Filed: January 14, 2005

Art Unit: 1792

For: METHOD OF DRY ETCHING, DRY  
ETCHING GAS AND PROCESS FOR  
PRODUCING PERFLUORO-2-PENTYNE

Examiner: S. Ahmed

**RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated February 5, 2009, please reconsider the rejections based on the remarks presented herein.

**Remarks begin on page 2 of this paper.**